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(Not for submission under 37 CFR 1.99)

Application Number	10645773
Filing Date	2003-08-21
First Named Inventor	Hidehiko Kawaguchi
Art Unit	1746 1792
Examiner Name	B. S. Carrillo
Attorney Docket Number	KAMMON 3.0-069 CONT

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2 /SC/	2	60034612	JP		1985-02-22	Toray Industries		<input checked="" type="checkbox"/>
3	3	62280700	JP		1987-12-05	Hitachi Ltd	<i>not considered no relevance or translation provided.</i>	<input type="checkbox"/>

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4	/SCI/	4	19738147	DE		1999-03-04	Steag Micro Tech Gmbh		<input checked="" type="checkbox"/>
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